INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

April 20, 2026

IGI Report Number	LG793628616
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	OVAL BRILLIANT
Measurements	12.68 X 7.56 X 4.67 MM

GRADING RESULTS

Carat Weight	2.83 CARATS
Color Grade	D
Clarity Grade	VVS 2

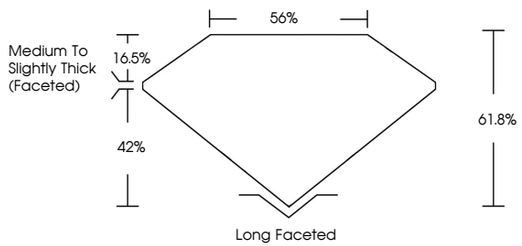
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG793628616

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG793628616
Report verification at igi.org

PROPORTIONS



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

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Medium To Slightly Thick (Faceted) 16.5% 42% 56% 61.8% Long Faceted

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Color Grade D
Clarity Grade VVS 2
Depth 61.8%
Table 56%
Girdle Medium To Slightly Thick (Faceted)
Culet Long Faceted
Polish EXCELLENT
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Fluorescence NONE
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